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Application No. Applicant(s)

Intonvious Summans	10/049,672	KURATA ET AL.	
Interview Summary	Examiner	Art Unit	
	DuyVu n. Deo	1765	
All participants (applicant, applicant's representative, PTO	personnel):		
1) <u>DuyVu n. Deo; Anita K. Alanko</u> .	(3) <u>Yasushi Kurata</u> .		
William I.Solomon. (4) Akira Terakado; Masayasu Saito.			
Date of Interview: <u>18 May 2005</u> .			
Type: a)☐ Telephonic b)☐ Video Conference c)☒ Personal [copy given to: 1)☒ applicant	2)⊠ applicant's representative	e]	
Exhibit shown or demonstration conducted: d) Yes If Yes, brief description:	e) No.		
Claim(s) discussed:			
Identification of prior art discussed: applied prior art.			
Agreement with respect to the claims f)☐ was reached.	g)⊡ was not reached. h)⊠ N	I/A.	
Substance of Interview including description of the general reached, or any other comments: discussed unexpected reached, or any other comments: discussed unexpected reached, or any other comments: discussed unexpected reached. Compared to Cu, and the overlapping ranges for or rejection (pH should cite concentration). (A fuller description, if necessary, and a copy of the amendallowable, if available, must be attached. Also, where no allowable is available, a summary thereof must be attached. THE FORMAL WRITTEN REPLY TO THE LAST OFFICE ANTERVIEW. (See MPEP Section 713.04). If a reply to the GIVEN ONE MONTH FROM THIS INTERVIEW DATE, OFFORM, WHICHEVER IS LATER, TO FILE A STATEMENT Summary of Record of Interview requirements on reverse sections.	esults (please see atttached), in exidizing agent concentration and exidizing agent concentration and exidizing agent concentration and examiner agroups of the amendments that vid.) ACTION MUST INCLUDE THE RELIANCE ACTION AUST INCLUDE THE ELEMAILING DATE OF THE OF THE SUBSTANCE OF THE OF THE SUBSTANCE OF THE EXAMILING CONCENTRATION AND AUTOMATICAL CONTRACTION AUTOMATICAL CONTRACTION AND AUTOMATICAL CONTRACTION AND AUTOMATICAL CONTRACTION AND AUTOMATICAL CONTRACTION AUTOMATICAL CONTRACTION AND AUTOMATICAL CONTRACTION AUTOMATICAL CON	reed would rend would render the SUBSTANCE (been filed, APP SINTERVIEW S	polishing ussed 112 er the claims claims OF THE PLICANT IS
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Examiner Note: You must sign this form unless it is an Attachment to a signed Office action.

Examiner's signature, if required

Summary of Record of Interview Requirements

Manual of Patent Examining Procedure (MPEP), Section 713.04, Substance of Interview Must be Made of Record

A complete written statement as to the substance of any face-to-face, video conference, or telephone interview with regard to an application must be made of record in the application whether or not an agreement with the examiner was reached at the interview.

Title 37 Code of Federal Regulations (CFR) § 1.133 Interviews

Paragraph (b)

In every instance where reconsideration is requested in view of an interview with an examiner, a complete written statement of the reasons presented at the interview as warranting favorable action must be filed by the applicant. An interview does not remove the necessity for reply to Office action as specified in §§ 1.111, 1.135. (35 U.S.C. 132)

37 CFR §1.2 Business to be transacted in writing.

All business with the Patent or Trademark Office should be transacted in writing. The personal attendance of applicants or their attorneys or agents at the Patent and Trademark Office is unnecessary. The action of the Patent and Trademark Office will be based exclusively on the written record in the Office. No attention will be paid to any alleged oral promise, stipulation, or understanding in relation to which there is disagreement or doubt.

The action of the Patent and Trademark Office cannot be based exclusively on the written record in the Office if that record is itself incomplete through the failure to record the substance of interviews.

It is the responsibility of the applicant or the attorney or agent to make the substance of an interview of record in the application file, unless the examiner indicates he or she will do so. It is the examiner's responsibility to see that such a record is made and to correct material inaccuracies which bear directly on the question of patentability.

Examiners must complete an Interview Summary Form for each interview held where a matter of substance has been discussed during the interview by checking the appropriate boxes and filling in the blanks. Discussions regarding only procedural matters, directed solely to restriction requirements for which interview recordation is otherwise provided for in Section 812.01 of the Manual of Patent Examining Procedure, or pointing out typographical errors or unreadable script in Office actions or the like, are excluded from the interview recordation procedures below. Where the substance of an interview is completely recorded in an Examiners Amendment, no separate Interview Summary Record is required.

The Interview Summary Form shall be given an appropriate Paper No., placed in the right hand portion of the file, and listed on the "Contents" section of the file wrapper. In a personal interview, a duplicate of the Form is given to the applicant (or attorney or agent) at the conclusion of the interview. In the case of a telephone or video-conference interview, the copy is mailed to the applicant's correspondence address either with or prior to the next official communication. If additional correspondence from the examiner is not likely before an allowance or if other circumstances dictate, the Form should be mailed promptly after the interview rather than with the next official communication.

The Form provides for recordation of the following information:

- Application Number (Series Code and Serial Number)
- Name of applicant
- Name of examiner
- Date of interview
- Type of interview (telephonic, video-conference, or personal)
- Name of participant(s) (applicant, attorney or agent, examiner, other PTO personnel, etc.)
- An indication whether or not an exhibit was shown or a demonstration conducted
- An identification of the specific prior art discussed
- An indication whether an agreement was reached and if so, a description of the general nature of the agreement (may be by
 attachment of a copy of amendments or claims agreed as being allowable). Note: Agreement as to allowability is tentative and does
 not restrict further action by the examiner to the contrary.
- The signature of the examiner who conducted the interview (if Form is not an attachment to a signed Office action)

It is desirable that the examiner orally remind the applicant of his or her obligation to record the substance of the interview of each case. It should be noted, however, that the Interview Summary Form will not normally be considered a complete and proper recordation of the interview unless it includes, or is supplemented by the applicant or the examiner to include, all of the applicable items required below concerning the substance of the interview.

A complete and proper recordation of the substance of any interview should include at least the following applicable items:

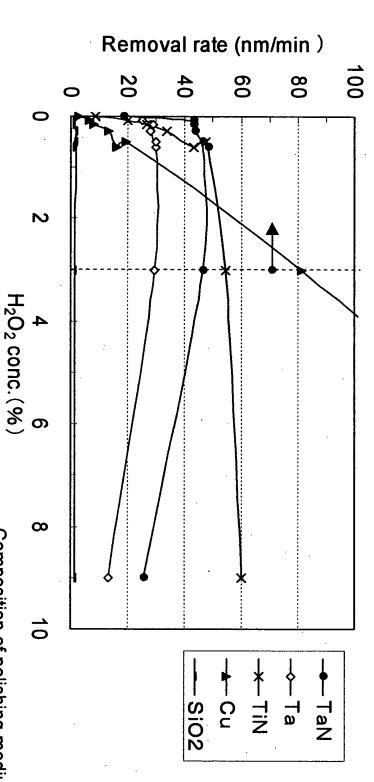
- 1) A brief description of the nature of any exhibit shown or any demonstration conducted,
- 2) an identification of the claims discussed,
- 3) an identification of the specific prior art discussed,
- 4) an identification of the principal proposed amendments of a substantive nature discussed, unless these are already described on the Interview Summary Form completed by the Examiner,
- 5) a brief identification of the general thrust of the principal arguments presented to the examiner,
 - (The identification of arguments need not be lengthy or elaborate. A verbatim or highly detailed description of the arguments is not required. The identification of the arguments is sufficient if the general nature or thrust of the principal arguments made to the examiner can be understood in the context of the application file. Of course, the applicant may desire to emphasize and fully describe those arguments which he or she feels were or might be persuasive to the examiner.)
- 6) a general indication of any other pertinent matters discussed, and
- 7) if appropriate, the general results or outcome of the interview unless already described in the Interview Summary Form completed by the examiner.

Examiners are expected to carefully review the applicant's record of the substance of an interview. If the record is not complete and accurate, the examiner will give the applicant an extendable one month time period to correct the record.

Examiner to Check for Accuracy

If the claims are allowable for other reasons of record, the examiner should send a letter setting forth the examiner's version of the statement attributed to him or her. If the record is complete and accurate, the examiner should place the indication, "Interview Record OK" on the paper recording the substance of the interview along with the date and the examiner's initials.

Impact of H₂O₂ conc. on R.R.



Low H_2O_2 conc. (\leq 3.0wt%) shows high Ta removal rate and low Cu removal rate.

Composition of polishing medium BTA 0.2wt%
MeOH 0.6wt%
Colloidal silica(32nm) 1wt%
H₂O₂ 0-9wt%
Malic acid 0.5wt%

niconductor Materials Div

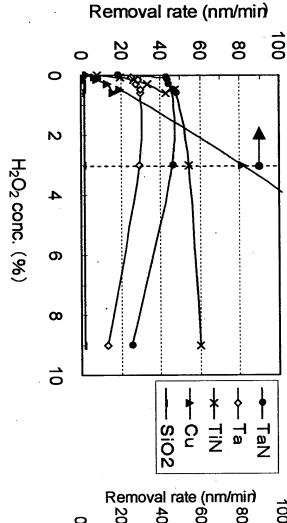
Hitachi **Chemical**



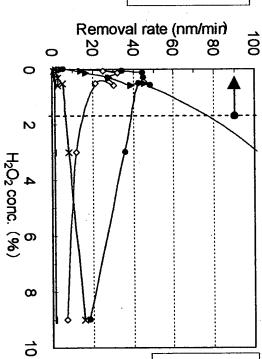
mpact of H₂O₂ conc. on R.R.



PAA: 0wt%



PAA: 0.05wt%



* Tik † Cu **-SiO2**

Slurry with PAA:0.05wt% shows high R.R. at lower H₂O₂ conc.

H₂O₂ 0-9wt% Malic acid 0.5wt% BTA 0.2wt% PAA 0wt% or 0.05wt% Composition of polishing medium MeOH 0.6wt% Colloidal silica(32nm) 1wt%

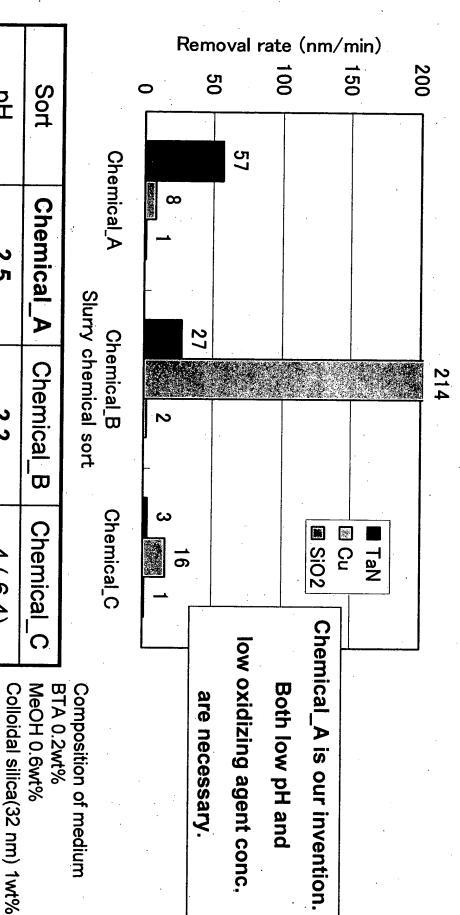
Hitachi Chemical



euctor Materials Div



Chemical effect on removal rate



Semiconductor Materials Div

H₂O₂ conc.

0.15%

9%

0.15%

얼

2.5

2.2

4 (-6.4)

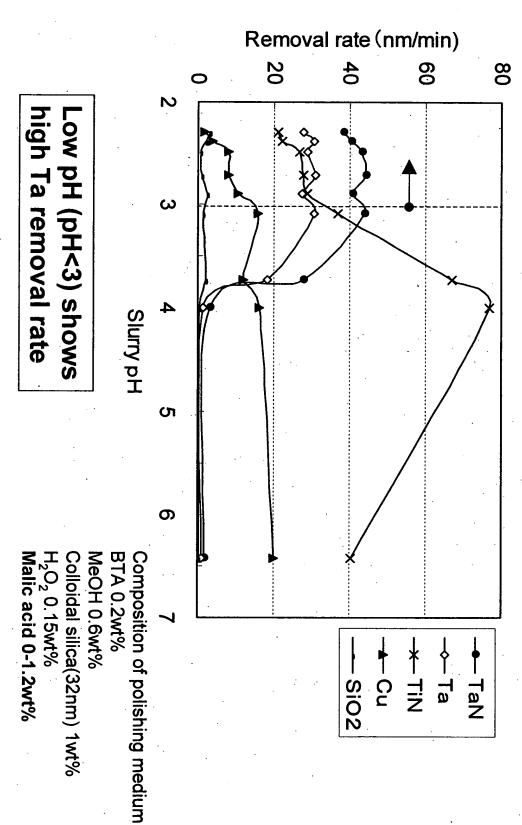
H₂O₂ 0-9wt%

Mallic acid 0.005-0.5wt%

Hitachi **Chemical**

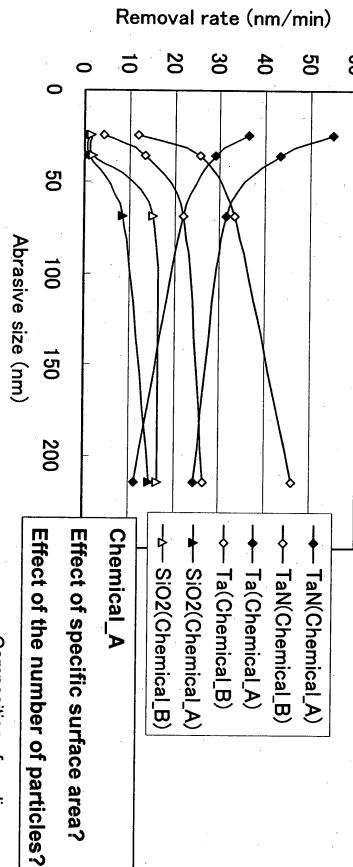


mpact of pH conc. on R.R.



Chemical effect on removal rate





=>Polishing mechanism (Reaction layer) is different. opposite tendency on Ta, TaN removal rate Chemical_A and Chemical_B show

Chemical A: Chemical effect > Mechanical effect

Composition of medium BTA 0.2wt%
MeOH 0.6wt%
Colloidal silica(32 nm) 1wt%
H₂O₂ 0.15wt% or 9wt%
Mallic acid 0.5wt%

Semiconductor Materials Div.

Hitachi **Chemical**

